

	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/720,579	KIM ET AL.	
ſ	Examiner	Art Unit	
	Edna Wong	1753	

	SEAR	CHED	
Class	Subclass	Date	Examiner
205	77	8/15/2007	EW
205	143	8/15/2007	EW
205	152	8/15/2007	EW
205	220	8/15/2007	EW
205	296	8/15/2007	EW

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
,				
			_	

	CH NOTES ARCH STRATEGY)
	DATE	EXMR
Inventor Search	8/15/2007	EW
EAST .	8/15/2007	EW
STN	8/15/2007	EW